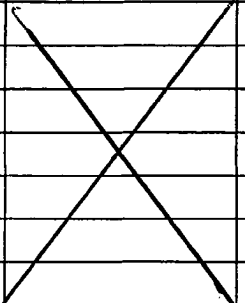


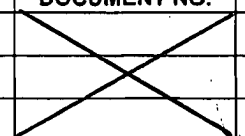
(PART of #1A/IDS)

PTO-1449 Information Disclosure Citation in an Application	Application No. 10644721	Applicant(s) Mohammed N. Islam et al.	
	Docket Number 074036.0124	Group Art Unit 2873	Filing Date August 20, 2003

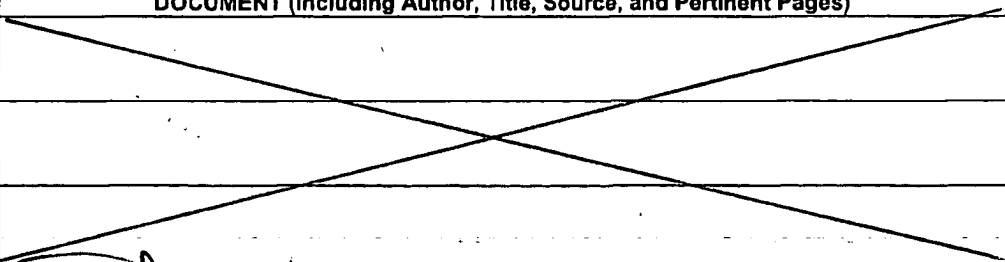
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DIS	B	6,407,851 B1	06/18/2002	Islam et al.	359	291	08/01/2000
DIS	C	2003/0081878 A1	05/01/2003	Joyner et al.	385	14	10/08/2002
DIS	D	2003/0086465 A1	05/08/2003	Peters et al.	372	50	10/30/2002
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DIS	G	6,611,366 B1	08/26/2003	Islam et al.	359	291	04/22/2002
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(PART of # 1B/IDS)

PTO-1449 Information Disclosure Citation in an Application	Application No. 10/644721	Applicant(s) Mohammed N. Islam et al.	
	Docket Number 074036.0124	Group Art Unit 2873	Filing Date August 20, 2003

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	B	4,900,119	02/13/90	Hill, et al.	359-350	571-96-45	04/01/88
	C	5,103,340	04/07/1992	Dono et al.	385	46	08/07/1991
	D	5,212,743	05/18/93	Heismann	385	11	02/12/92
	E	5,291,502	03/01/1994	Pezeshki et al.	372	20	09/04/1992
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	I	5,500,761	03/19/96	Goossen, et al.	359	290	01/27/94
	J	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95
	K	5,659,418	08/19/97	Yurke	359	290	02/05/96
	L	5,661,592	08/26/97	Bornstein, et al.	359	291	01/07/95
	M	5,701,193	12/23/97	Vogel, et al.	359	290	02/21/96
	N	5,745,271	04/28/98	Ford, et al.	359	130	07/31/96

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DIS	O	0 667 548 A1	16.08.1995	EP	G02B	26/02	X	
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PTO-1449 Information Disclosure Citation in an Application	Application No. 10/644721	Applicant(s) Mohammed N. Islam et al.	
	Docket Number 074036.0124	Group Art Unit 2873	Filing Date August 20, 2003

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	C	5,825,528	10/20/98	Goossen	359	291	12/26/95
	D	5,835,255	11/10/98	Miles	359	291	05/05/94
	E	5,841,579	11/24/98	Bloom, et al.	359	572	06/07/95
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	G	5,870,221	02/09/99	Goossen	359	290	07/25/97
	H	5,909,303	06/01/1999	Trezza et al.	359	248	01/03/1997
	I	5,914,804	06/22/99	Goossen	359	291	01/28/98
	J	5,920,391	07/06/1999	Grasdepot et al.	356	352	04/22/1998
	K	5,943,155	08/24/99	Goossen	359	247	08/12/98
	L	5,943,158	08/24/99	Ford, et al.	359	295	05/05/98
	M	5,943,454	08/24/99	Aksyuk, et al.	385	22	08/15/97
	N	5,949,571	09/07/99	Goossen, et al.	359	291	07/30/98

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DIS ↓	O	0 788 005 A2	06.08.1997	EP	G02B	26/02	X	
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(PART of #186DS)

PTO-1449	Application No. 10/644721	Applicant(s) Mohammed N. Islam et al.	
Information Disclosure Citation in an Application	Docket Number 074036.0124	Group Art Unit 2873	Filing Date August 20, 2003

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	C	5,974,207	10/26/99	Aksyuk, et al.	385	24	12/23/97
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DIS	N	01/67156 A2	13.09.2001	WO	G02B	26/00	X	
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(PART OF #18/IDS)

PTO-1449		Application No. 10/644721		Applicant(s) Mohammed N. Islam et al.	
Information Disclosure Citation in an Application		Docket Number 074036.0124		Group Art Unit 2873	Filing Date August 20, 2003

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DIS ↓ ↓ ↓ ↓ ↓	A	6,341,039 B1	01/22/2002	Flanders et al.	359	578	08/25/2000
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DIS ↓ ↓ ↓ ↓ ↓	F	WO 01/37021 A1	14.11.2000	PCT	G02B	6/42	X	
	G	WO 01/79795 A1	22.03.2001	PCT	G01J	3/28	X	
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(PART OF #18 LIDS)

PTO-1449	Application No.	Applicant(s)	
	10/644721	Mohammed N. Islam et al.	
Information Disclosure Citation in an Application	Docket Number	Group Art Unit	Filing Date
	074036.0124	2873	August 20, 2003

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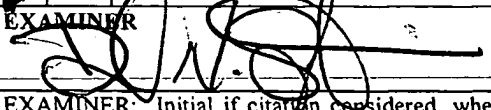
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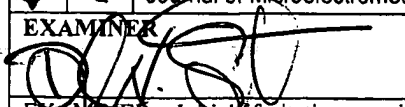
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PTO-1449		Application No. 10/644 721		Applicant(s) Mohammed N. Islam et al.				
Information Disclosure Citation in an Application		Docket Number 074036.0124		Group Art Unit 2873	Filing Date August 20, 2003			
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PTO-1449

**Information Disclosure Citation
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Applicant(s)

Mohammed N. Islam et al.

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U.S. PATENT DOCUMENTS

		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A						
	B						
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	G						
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	M							

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
DB	N	Goossen et al., "Micromechanical Gain Slope Compensator for Spectrally linear Optical Power Equalization," IEEE Photonics Technology Letters, Vol. 12, No. 7, pp. 831-833	07/2000
DB	O	Goossen et al., "Integrated mechanical anti-reflection switch (MARS) device for fiber-to-the-home applications," http://mirlynweb.lib.umich.edu/WebZ/FETCH?sessionId=01-35557-462149016&recno=13&re	05/08/2002
DB	P	"ELASTIC-45 tunable interferometer component," Solus, Preliminary Datasheet and applications	Undated
	Q		
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